

<b>Notice of References Cited</b>	Application/Control No. 10/574,580		Applicant(s)/Patent Under Reexamination KAWATO ET AL.	
	Examiner Hai Vo		Art Unit 1794	Page 1 of 1

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*	C	US-5,854,294	12-1998	Hirosawa et al.	521/79
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